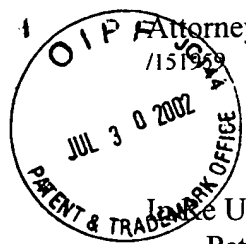


3729



PATENT

#4

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor U.S. Patent Application Of:
Peter V. Loeppert and Sung Bok Lee

Group Art Unit: 3729

Application No.: 09/910,110
Confirmation No.: 1681

Examiner: Not Yet Assigned

Filed: July 20, 2001

For: **Improved Raised Microstructure of
Silicon Based Device**

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SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT
BEFORE THE MAILING DATE OF A FIRST OFFICE ACTION (37 CFR§1.97(b))

Pursuant to 37 CFR §1.97(b), Applicant submit Patents identified on the attached Supplemental Information Disclosure Statement (PTO-1449).

Since this Statement is being filed before the mailing date of the first Office Action on the merits, no certification or fee is necessary.

Respectfully submitted,

Date: July 23, 2002

By: Thomas K. Stine
Thomas K. Stine, Registration No. 32,310
WALLENSTEIN & WAGNER, LTD.
311 South Wacker Drive, 53rd Floor
Chicago, Illinois 60606-6630
312-554-3300
Attorneys for Applicants

CERTIFICATE OF MAILING (37 C.F.R. § 1.8a)
I hereby certify that this correspondence is, on the date shown below, being deposited with the United States Postal Service as first class mail, postage prepaid, in an envelope addressed to: Commissioner For Patents, Washington, D.C. 20231 on July 23, 2002

Lora B. Thomas
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